

#3/Preamble
1. Independent
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jacson Liu

Examiner: Guerrero, M

Filing Date: 11/03/98

Art Unit: 2822

Serial No.: 09/187,197

Docket No.: MVI-005

Title: SHALLOW TRENCH ISOLATION METHOD FOR A SEMICONDUCTOR
WAFER

To: The Commissioner of Patents and Trademarks
Washington, D.C. 20231

Subject: Response to the Office Action dated 02/17/99

Dear Sir:

AMENDMENT

In response to the Office Action identified above, please
amend the above-identified application as follows:

Cancel claim 14-19.

1. Restriction to claims 1-19:

Claims 1-19 are pending in this application. Restriction to one of the following invention is required under 35 U.S.C. § 121: I. Claim 14-19, drawn to a semiconductor device, classified in class 257, subclass 301. II. Claim 1-13, drawn to a process of making a semiconductor device apparatus, classified in class 438, subclass 427. Applicant is advised that the response to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 C.F.R. 1.143).

Response:

Applicant accepts the Examiner's opinion and amends the claims in the above AMENDMENT portion according to 37 C.F.R. 1.143. The method claims of claims 1-13 are elected as the subject matter to be examined in the present application. The product claims of claims 14-19 are non-elected and therefore canceled. Reconsideration over claims 1-13 is hereby request.

Sincerely yours,

Winston Hsu

Winston Hsu
U.S. Patent agent
Reg. No.: 41,526

Date: 3/11/1999